



PATENT APPLICATION  
Docket No. 2522-013  
Client No. AW6028US/JS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tae-Ho Jang                      Conf. No.      9968  
Serial No.                      10/076,237                      Examiner:      Maria F. Guerrero  
Filed:                      February 13, 2002                      Art Unit:      2822  
For:                      SILICON-ON-INSULATOR (SOI) SUBSTRATE AND METHOD  
                                 MANUFACTURING THE SAME

MAIL STOP NON FEE AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the non-final Office Action dated October 6, 2003, please amend the application as follows.

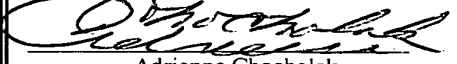
**Amendments to the Claims** begin on page 2 of this paper.

**Amendments to the Specification** begin on page 6 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Non Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450  
Date: January 5, 2004

  
Adrienne Chocholak